



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

*IFW*

In re application of:

STADLER et al.

Group Art Unit: 1765

Examiner: Shamim Ahmed

Serial No.: 10/686,365

Filed: October 15, 2003

For: PROCESS AND DEVICE FOR THE WET-CHEMICAL  
TREATMENT OF SILICON

Attorney Docket No.: WSAG 0131 PUS

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Mail Stop Amendment  
Commissioner for Patents  
U.S. Patent and Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated September 28, 2005, kindly amend the  
above-identified application as follows:

**CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8 (FIRST CLASS MAIL)**

I hereby certify that this paper, including all enclosures referred to herein, is being deposited with the United States Postal Service as first-class mail, postage pre-paid, in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, U.S. Patent and Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450 on:

December 14, 2005

Date of Deposit

William G. Conger

Name of Person Signing



Signature